

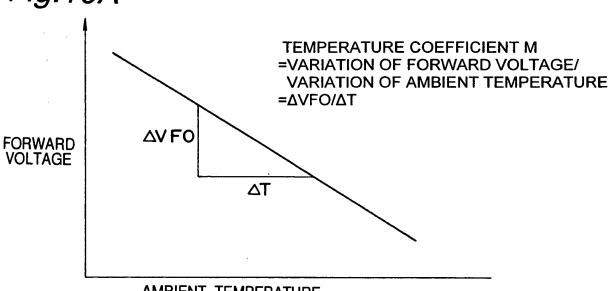
App No.: 09/987,010

Docket No.: 204552021700

Inventor: Tetsuyoshi INOUE
Title: SEMICONDUCTOR LASER MANUFACTURING METHOD
AND SEMICONDUCTOR LASER

REPLACEMENT SHEET





AMBIENT TEMPERATURE -

Fig.10B

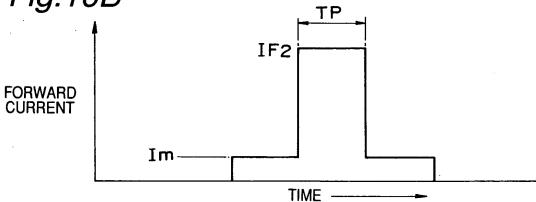


Fig.10C

